


Search Notes 	Application/Control No. 10596294	Applicant(s)/Patent Under Reexamination WAKIYAMA, KOJI
	Examiner Jason Heidemann	Art Unit 2624

SEARCHED

Class	Subclass	Date	Examiner
348	61,77,78,207.99,207.1,156	10/14/2009	/JEH/
340	5.2,5.52,5.53,5.8,5.82,5.83,540,426.1	10/14/2009	/JEH/
351	200,205,206,209	10/14/2009	/JEH/
382	100,115,117,118	10/14/2009	/JEH/
396	155,14,18,	10/14/2009	/JEH/
713	182,185,186	10/14/2009	/JEH/

SEARCH NOTES

Search Notes	Date	Examiner
Searched Class and Subclass with Keywords (iris, focus, authentication, etc)	10/14/2009	/JEH/
Searched Google, ACM, and IEEE with keywords (iris focus, multiple focus ranges, etc)	10/14/2009	/JEH/
Author Search conducted on East	10/14/2009	/JEH/
Author Search Conducted on Google, ACM, and IEEE	10/14/2009	/JEH/

INTERFERENCE SEARCH

Class	Subclass	Date	Examiner

/Jason Heidemann/
Examiner, Art Unit 2624

10/14/2009